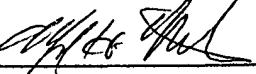




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1762  
JPM

I, Alfred H. Muratori,  certify that this paper was deposited with the United States Postal Service addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450, first class, postage prepaid on Saturday, April 16, 2005.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hunt et al.

Group art: 1762

Application No.: 09/748,714

Examiner: Timothy Howard Meeks

Filing date: 21 December 2000

For: CHEMICAL VAPOR DEPOSITION METHODS FOR MAKING POWDERS  
AND COATINGS, AND COATINGS MADE USING THESE METHODS

Response to Notice of Non-Compliant Amendment

**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

Sir:

In response to the Notice of Non-Compliant Amendment dated 16 March, 2005, please replace the final paragraph on page 5 (Appendix B submitted with the amendment of 2/12/05) with Appendix B as shown below.

Remarks

The paragraph submitted with new Appendix B has been amended to show markings.

Respectfully submitted,



Alfred H. Muratori  
Reg. No. 41,561  
Agent for Applicant

April 16, 2005

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